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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicants: Bhandari, Gautan, Gall.

Application No.: 09/483,859

Date Filed: January 17, 2006

Title: TANTALUM AMIDE RADE LANGE OF PRECURSORS FOR DEPOSITION OF TANTALUM NITRIDE ON A SUBSTRATE

23448

PATENT TRADEMARK OFFICE

Examiner:

Not yet assigned

Group Art Unit:

1742

Paper No.:

2

FIRST CLASS MAILING CERTIFICATE

I hereby certify that this paper is being deposited this date with the U.S. Postal Service as First Class Mail in an envelope addressed to the U.S. Patent and Trademark Office, Assistant Commissioner for Patents, Office of Initial Patent Examination Customer Service Center, Washington, DC 20231, under the provisions of 37 CFR 1.8.

April 25, 2000 Date Mailed

FURTHER REQUEST FOR ISSUE OF CORRECTED FILING RECEIPT IN U.S. APPLICATION NO. 09/483,859

U.S. Patent and Trademark Office Assistant Commissioner for Patents Office of Initial Patent Examination Customer Service Center Washington, DC 20231 Sir:

A further review of the Filing Receipt issued for the above-identified patent application has revealed the presence of an additional error, in misspelling of the name of co-inventor Thomas H. Baum, whose last name was misspelled "Bawn."

A copy of the Filing Receipt is enclosed, as earlier submitted, and as now further corrected with respect to the co-inventor Baum's last name.

Please issue a fully corrected Filing Receipt for this application.

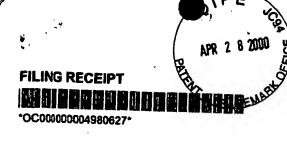
Respectfully submitted,

Steven J. Huliquist Registration No. 28,021 Attorney for Applicant

INTELLECTUAL PROPERTY/ TECHNOLOGY LAW

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| | FILING DATE | | | | | | | |
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| APPLICATION NUMBER | | GRP ART UNIT | FIL FEE REC'D | ATTY.DOCKET.NO | DRAWINGS | TOT CLAIMS | IND CLAIMS | |
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| Steven J. Hultquist Intellectual Property/Technology Law Post Office Box 14329 Research Triangle Park, NC 27709 | | | | 2771-221 | | | | |
| | | | | | Da | ate Møjled: (| 03/02/2000 | |

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Bhandari Gautam, Danbury, CT; Thomas H. Bawm, New Fairfield, CT;

Continuing Data as Claimed by Applicant
This is a division of U.S. Patent Application No. 09/012,679 filed January 23, 1998
and issued January 18, 2000 as U.S. Patent 6,015,917.
Foreign Applications

Title

BEST AVAILABLE COPY

Tantalum amide precursors for deposition of tantalum nitride on a substrate

Preliminary Class

420

Data entry by : BLIZZARD, SHARON

Team : OIPE

Date: 03/02/2000